Measurement of Ultra Low Transverse Emittance at REGAE

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Abstract

The linear accelerator REGAE at DESY produces short and low charged electron bunches, on the one hand to resolve the excitation transitions of atoms temporally by pump-probe electron diffraction experiments and on the other hand to investigate principal mechanisms of laser plasma acceleration. For both cases a high quality electron beam is required which can be identified with a small beam emittance. A standard magnet scan is used for the emittance measurement which is in case of a low charged bunch most sensitive to the beam size determination (RMS or 2nd central moment of a distribution). Therefore the diagnostic and a routine to calculate proper central moments of an arbitrary distribution will be introduced and discussed.

Keywords: electron beam diagnostic, low charge application

1. Introduction

The Relativistic Electron Gun for Atomic Exploration (REGAE, Fig. 1) at DESY is a small 5 MeV linear accelerator with a bunch charge range of a few to some hundreds fC. The beam energy is delivered by an S-band photo-injector cavity. In addition to the gun a 4-cell buncher cavity is installed. It is designed for ballistic bunching down to 10 fs. Due to the low energy a beam optics consisting of compact, symmetrically focusing solenoids is sufficient. The machine is built for two types of experiments: first a time-resolved electron diffraction experiment in order to make atomic transitions ‘visible’ [1, 2] and secondly investigations of new plasma-wakefield acceleration schemes [3]. Both experiments require a low transverse beam emittance down to 10 nm (normalized emittance). Hence, there are two challenges: generate such a high quality and low-charge electron bunch and measure its quality with high precision which is discussed below.

Due to the small energy spread as well as in first approximation negligible space charge effects a phase advance method can be utilized for the emittance measurement. For this purpose a charge sensitive detector system was developed which has the required spatial resolution to measure the beam profile despite the unavoidable noise and background signals.

2. Emittance measurement via a solenoid scan

2.1. Phase advance method

A commonly used method to determine the transverse emittance of an electron bunch is a magnet scan. Here the phase advance between a magnet and a downstream screen is changed by varying the magnet current. Analyzing the RMS beam size as function of the focusing strength yields the emittance. Alternatively, it is possible to measure the beam size at different positions without any additional change of the optics. At REGAE the first method is used.

Assuming a small energy spread the trace space emittance is determined as

$$\epsilon_x = \sqrt{\langle x^2 \rangle \langle x'^2 \rangle - \langle xx' \rangle^2} \quad (1)$$

with x as the transverse particle position and x' as the transverse angle relative to the longitudinal axis. The trace space emittance is related in the following way to the normalized emittance:

$$\epsilon_x = \frac{1}{\beta \gamma} \epsilon_{n,x} \quad \text{with} \ \beta = v/c, \ \text{the Lorentz factor} \ \gamma, \ \text{the velocity} \ v \ \text{and the speed of light} \ c.$$  

Furthermore, $\langle \rangle$ denotes the central moment of a distribution, in this
case the 2nd central moment where the square root
is normally called RMS: $\langle x^2 \rangle = x_{rms}^2$.
In order to measure the transverse beam emittance
the envelope equation can be used [4]:

$$x_{rms}^2 = \left(R_{11}^2 + 2R_{11}R_{12} + R_{12}^2\right)^\top \begin{pmatrix} a_1 \\ a_2 \\ a_3 \end{pmatrix} \tag{2}$$

with $a_1 = x_{0,rms}^2$
$a_2 = x_{0,rms}(x_{0,rms})'$
$a_3 = \frac{x_{0,rms}^2}{2} + (x_{0,rms})'^2$.

$x_{rms}$ denotes the RMS beam size at the screen,
$x_{0,rms}$ the beam size and $(x_{0,rms})'$ the envelope
slope at the entrance of the solenoid. $R$ denotes
the transfer matrix between the solenoid and the
screen. In order to calculate the RMS beam size
a Gaussian fit is often used. But the width of the
normal distribution is only equal to the RMS if the
beam profile is really normal distributed. In any
other case this assumption doesn’t hold which falsi-
sifies the results. It is important to emphasize that
Eq. 2 holds for RMS quantities. But the calculation
of the RMS is difficult because the pure beam sig-
nal has to be separated from background and noise
signals which can not be avoided - just reduced.
A post-processing routine for images will be intro-
duced in the next section.
Taking Eq. 2 as a model describing the beam size
development at a certain position in dependence of
varying phase advances, the emittance can be found
with the method of least-squares.

2.2. Detector system at REGAE

For the diffraction experiment at REGAE a
highly sensitive detector system is installed which is
capable of detecting single electrons. This detector
combined with the solenoids Sol45 or Sol67 (Fig. 1)
can be used for the emittance measurements. The
detector contains a CsI-crystal-screen which is
grown onto light guides, called FOS (Fiber Optics
Scintillator) and was manufactured by Hamamatsu
Photonics [5], and the Andor iXon Ultra 888 cam-
era [6] with a charge sensitive Electron-Multiplying
CCD (EMCCD). The pixel size of the CCD is 13 $\mu$m
and the size of each fiber of the FOS is $\sim 6$ $\mu$m.
The overall spatial resolution of this detector sys-
tem is $\sim 16$ $\mu$m due to optics between scintillator
and the EMCCD camera. For all presented mea-
surements and results this resolution is sufficient.
Due to the long drift section between the solenoids
and the detector the smallest measured beam size
is larger than 50 $\mu$m.

A schematic layout of the detector is shown in
Fig. 2. The FOS is orientated perpendicular to the
beam propagation. To avoid high energy photons
or electrons hitting the EMCCD camera a mirror
reflects the visible light emitted by the FOS under
90° in direction of the camera. An Aluminum cover,
directly layered onto the FOS reflects the emitted
light of the FOS back in direction of the mirror.
The whole setup is light-tight and the EMCCD is
cooled down to $-70^\circ$C in order to reduce the noise
from stray light and electronics of the EMCCD, re-
respectively. All these factors increase the charge sen-
sitivity by a factor of $\sim 10^3$ compared to a 'stan-
dard scintillator-CCD-system' at REGAE ('Screen'
in Fig. 1).

2.3. EMCCD measurements and results

In case of ultra-low bunch charges down to a few
fC shot noise, the fluctuation of the number of elec-
trons from shot-to-shot, has a big contribution to
the signal-to-noise ratio of the actual detector sys-
tem at REGAE even if it is not the only significant factor. A new detector system is in the planning stage and should be sensitive enough that the shot noise is the limiting factor of this system. The new system will hit the limits of achievable sensitivity, but will improve the measurements for all kinds of experiments as well as diagnostic issues.

3. Image post-processing

Compared to a more sophisticated image post-processing routine we developed to deal for example with the shot noise as the main source of background signal [7], we are currently facing a broad and distinct halo which can be clearly seen with our detector system. An example is shown in Fig. 3. Investigations of the origin of the halo are still ongoing. Till now it could not be clarified whether it is electron beam related or an artifact of the detector system. Using collimators, which are cutting out a round part of the electron beam, is changing the proportion of the peaked signal and the halo but still the ratio of the halo is significant (> 15%) and cannot be ignored.

But nevertheless the effect of this halo on e.g. a diffraction experiment is small. A distinct image of a diffraction pattern is mainly depending on the geometry of the imaging system and the probe’s quality - in this case on the geometry and beam parameters of the REGAE accelerator. Therefore the peaked part of the beam with a higher beam quality (or smaller emittance) has the largest influence on the imaging of a diffraction pattern. As a consequence we decided to apply an intensity cut before using recorded data for further evaluations. The halo as well as the ‘peak on top’ can be described by the superposition of two Gaussian distributions:

\[
f(x) = a_1 \exp \left( - \frac{(x - \mu_1)^2}{2 \sigma_1^2} \right) + a_2 \exp \left( - \frac{(x - \mu_2)^2}{2 \sigma_2^2} \right), \tag{3}
\]

\( a_i \) is the distribution’s amplitude, \( \mu_i \) describes the barycenter and \( \sigma_i \) the standard deviation (or 2nd central moment) of each distribution with \( i = 1, 2 \).

The aim is to use only the peaked Gaussian profile for the described emittance measurement method (Sec. 2.1). Eq. 3 is used to fit the profiles of the focused beam to determine the cut-intensity in order to use it for the whole image set at a certain magnet current. The cut-intensity is defined as the integrated intensity of the first Gaussian distribution:

\[
I_{\text{cut}} = \int_{-\infty}^{\infty} a_1 \exp \left( - \frac{(x - \mu_1)^2}{2 \sigma_1^2} \right) dx,
\]

assuming \( a_1, \mu_1 \) and \( \sigma_1 \) are the parameters of the peaked Gaussian distribution. From the cut off profiles the needed 2nd central moments can be calculated and used for the emittance fit routine.

Figure 3: Measured beam profiles at REGAE - projections and 2D-colored profile. Double Gaussian fits (solid lines) were applied.

4. Measurements

Due to a repaired vacuum leak of the gun cavity only moderate field gradients up to 60 MV/m can be set presently. The cavity will be replaced but for now it limits the mean beam energy and the contributions of space charge effects to the emittance growth inside the gun cavity as well as during the beam transport are larger.

An exemplary emittance measurement is shown in Fig. 4. The measured mean beam energy was \( E_{\text{kin}} = 2.45 \text{ MeV} \). The bunch charge was determined as \( Q_{\text{bunch}} = 37.6(6) \text{ fC} \) - the number in brackets denotes the uncertainty of the last digit. The least-square fit parameters are shown in Tab. 1 (calculated following [8]). The goodness of the fit is estimated by the reduced Chi Square \( \chi^2 \) which should tend to one.

Another interesting concept which was investigated is the usage of collimators and the dependence on the emittance. With different diameters different amounts of charge can be cut out. A
reduced beam size reduces the emittance as well (Eq. 1). Due to the collimators an even smaller norm. trans. emittances could be achieved and measured. An emittance measurement for different collimator diameters is shown in Fig. 5. At the same time as the charge is reduced of course the space charge effects are reduced as well. Hence, the reduced emittance is not a pure effect of the beam size reduction.

5. Conclusion and Outlook

Ultra-low emittance measurements for ultra-low bunch charges could be successfully performed at REGAE. The limit of the introduced diagnostic method is showing up at the transition of signal to noise where a loss of information is unavoidable and cannot be regained. This loss could be minimized by the introduced detector system. In order to improve the sensitivity a new detector system will be setup at REGAE in the next months. The investigations of the observed halo are still ongoing.

Because always some relevant beam signal gets cut every introduced cut potentially falsify the results. Solving this issue offers the possibility to measure and determine the 'uncut-emittances' of the REGAE electron beam.

With higher mean beam energies space charge effects can be suppressed and more charge can be accelerated while the emittance is still conserved. The replacement of the REGAE gun cavity will help to achieve this and normalized transverse emittances down to $10^{-3}$ mm mrad at a few fC seem to be feasible.
References


